



Attorney Docket No. 0756-7263

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Shunpei YAMAZAKI et al.

Serial No. 10/799,626

Filed: March 15, 2004

For: LASER IRRADIATION APPRATUS,

LASER IRRADIATION METHOD,

AND METHOD FOR

MANUFACTURING A

SEMICONDUCTOR DEVICE

) Group Art Unit:

) Examiner:

) CERTIFICATE OF MAILING

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)

)

PRELIMINARY AMENDMENT

Honorable Commissioner of Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

Please consider the following amendments and remarks in connection with the above-identified application.

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks begin on page 11 of this paper.